

Hit Number	Hit Text	Search Text	Time stamp
2	(sensor sensitive) and ((silicone siloxane oxosilane) near 4 (film layer) and ((silicone siloxane oxosilane) same (structure formula) same ladder)	US-PAT; US-PPUB; EPO; JPO; DERWEIT US-PAT; US-PPUB; EPO; JPO; DERWEIT US-PPUB; EPO; JPO;	2002/12/04 15:44
10	diamond same (optical adj sensor).ab,ti.	US-PAT; US-PPUB; EPO; JPO;	2002/12/04 15:42
3	"0222537"	US-PAT; US-PPUB; EPO; JPO;	2002/12/04 15:42
18	(sensor sensitive) and ((silicone siloxane oxosilane) same (structure formula) same ladder)	US-PAT; US-PPUB; EPO; JPO; DERWEIT US-PAT; US-PPUB; EPO; JPO;	2002/12/04 15:45
2	"60062278"	US-PAT; US-PPUB; EPO; JPO;	2002/12/06 13:30
6	diamond same sensor,ab,ti. and (silicone siloxane oxosilane) (magnetoresistance flow acceleration pressure gas image)	US-PPUB; EPO; JPO; DERWEIT US-PAT; US-PPUB; EPO; JPO;	2002/12/06 16:00
59	(Yasuda Yukumi Taguchi Kawano).in, and sensor and silicone and magnetoresistance flow acceleration pressure gas image)	US-PPUB; EPO; JPO; DERWEIT US-PAT; US-PPUB; EPO; JPO;	2002/12/09 10:07